APR 18 2006

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 9635

Satoshi MAEMORI et al.

Attorney Docket No. 2001\_1300A

Serial No. 09/955,111

Group Art Unit 1752

Filed September 19, 2001

Examiner Sin J. Lee

POSITIVE-WORKING PHOTORESIST COMPOSITION AND PHOTOSENSITIVE MATERIAL USING SAME Mail Stop: Amendment

## **RESPONSE**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated February 2, 2006, please amend the present application as follows: